

| Ref # | Hits | Search Query                                                          | DBs                                                     | Default Operator | Plurals | Time Stamp       |
|-------|------|-----------------------------------------------------------------------|---------------------------------------------------------|------------------|---------|------------------|
| L1    | 1717 | sacrificial with conductive with layer                                | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/12/21 21:22 |
| L2    | 24   | I1 same heater                                                        | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/12/21 21:23 |
| L3    | 26   | I1 same resistive                                                     | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/12/21 21:23 |
| L4    | 0    | I2 and I3                                                             | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/12/21 21:23 |
| L5    | 50   | I2 or I3                                                              | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/12/21 21:29 |
| L6    | 21   | microelectromechanical and ((thermal adj conductivity) same membrane) | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2004/12/21 21:30 |